

Electronic Acknowledgement Receipt

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Application Number:	10801954
Confirmation Number:	2359
Title of Invention:	Method and system for analyzing defects of an integrated circuit wafer
First Named Inventor:	Shu-Sing Liao
Customer Number:	22470
Filer:	Warren Scott Wolfeld
Filer Authorized By:	
Attorney Docket Number:	MXIC 1555-1
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1		RESPONSE_A.pdf	219565	yes	10

	Multipart Description		
	Doc Desc	Start	End
	Response to Election / Restriction Filed	1	1
	Claims	2	9
	Applicant Arguments/Remarks Made in an Amendment	10	10
Warnings:			
Information:			
	Total Files Size (in bytes):	219565	

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If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

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If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.